

Status Forward Si-Tracker (FSD) and Beam Si-Tracker (SiBT)

N. Zamyatin on behalf of Forward Silicon Tracker team

11th Collaboration Meeting of the BM@N Experiment at the NICA Facility,
28-30 November 2023

Fluence can be estimated by the empirical formula:

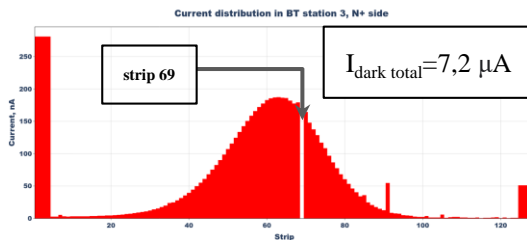
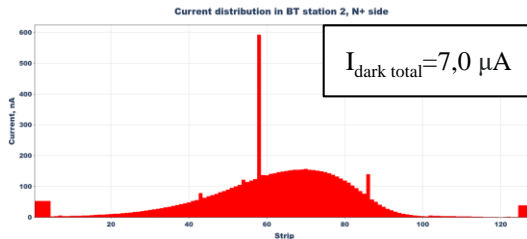
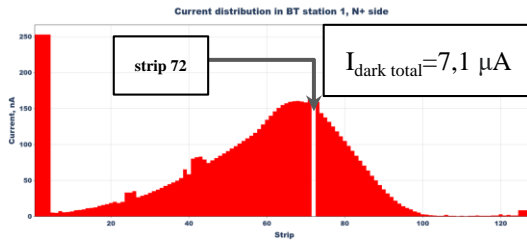
$$\Delta I = \alpha \cdot \Phi_n \cdot V_{det}$$

$$, \alpha = 3 \cdot 10^{-17} \text{ A} \cdot \text{cm}^{-1}, V_{det} = 61 \cdot 61 \cdot 0.175 \text{ mm}^3$$

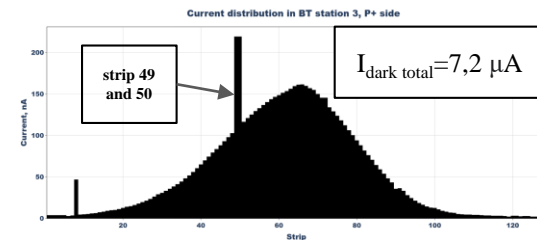
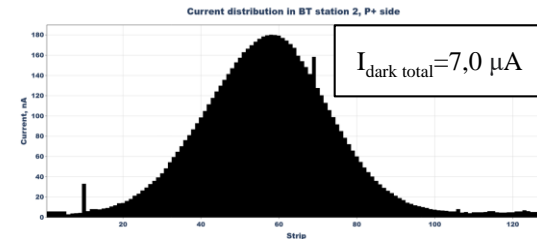
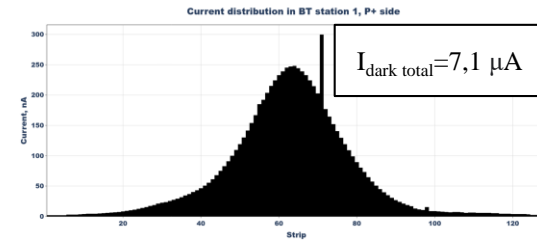
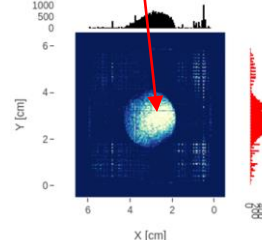
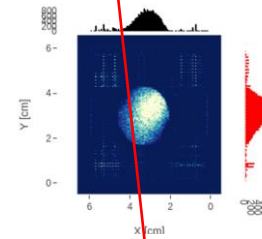
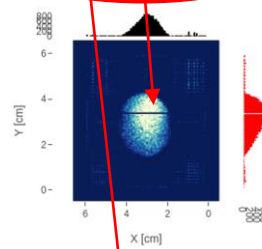
Total number of Xe-nuclei during run 2022-2023: $4.44 \cdot 10^{10}$

$$\Phi_n = k \cdot \Phi_{Xe}$$

k - hardness factor of 4 A*GeV Xe, k = 276

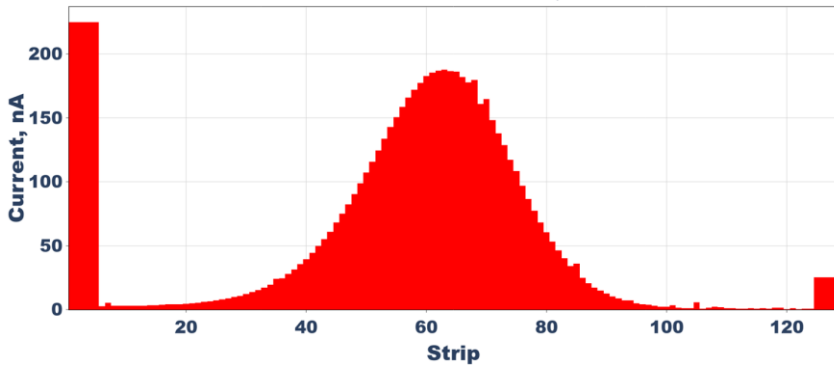


defects have been found

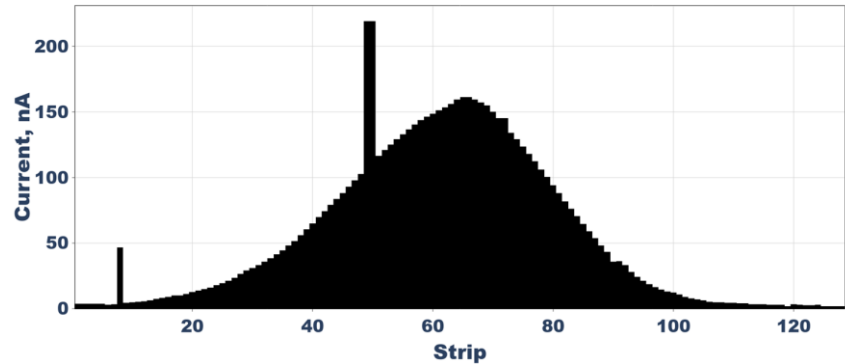


run 6705,
13.12.2022

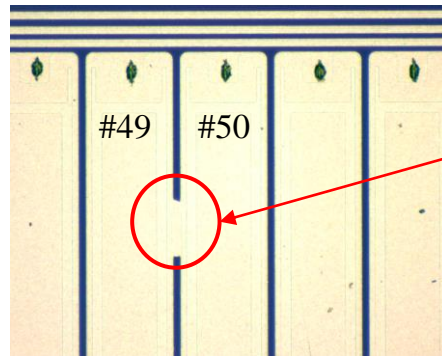
Current distribution in BT station 3, N+ side after fix



Current distribution in BT station 3, P+ side

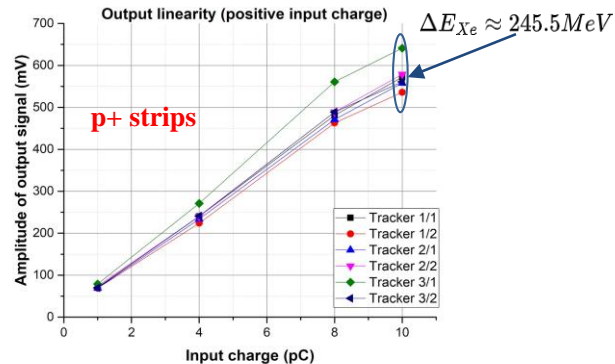
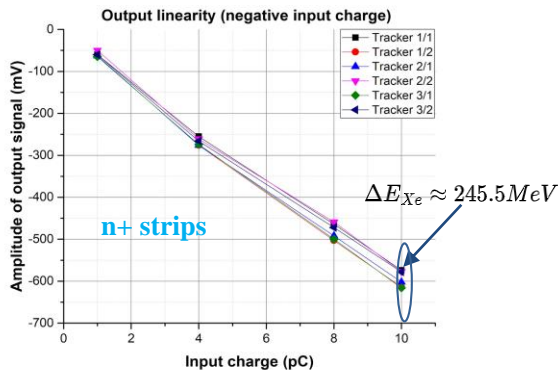


There was no pin connect #69 on the connector

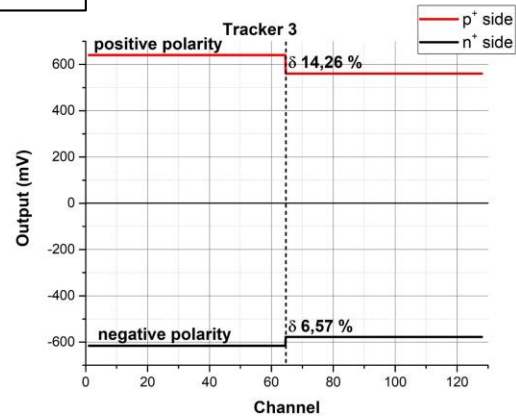
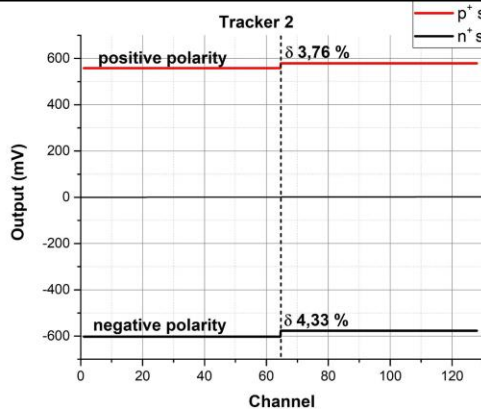
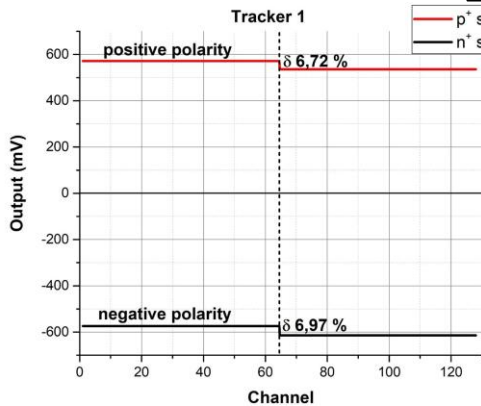


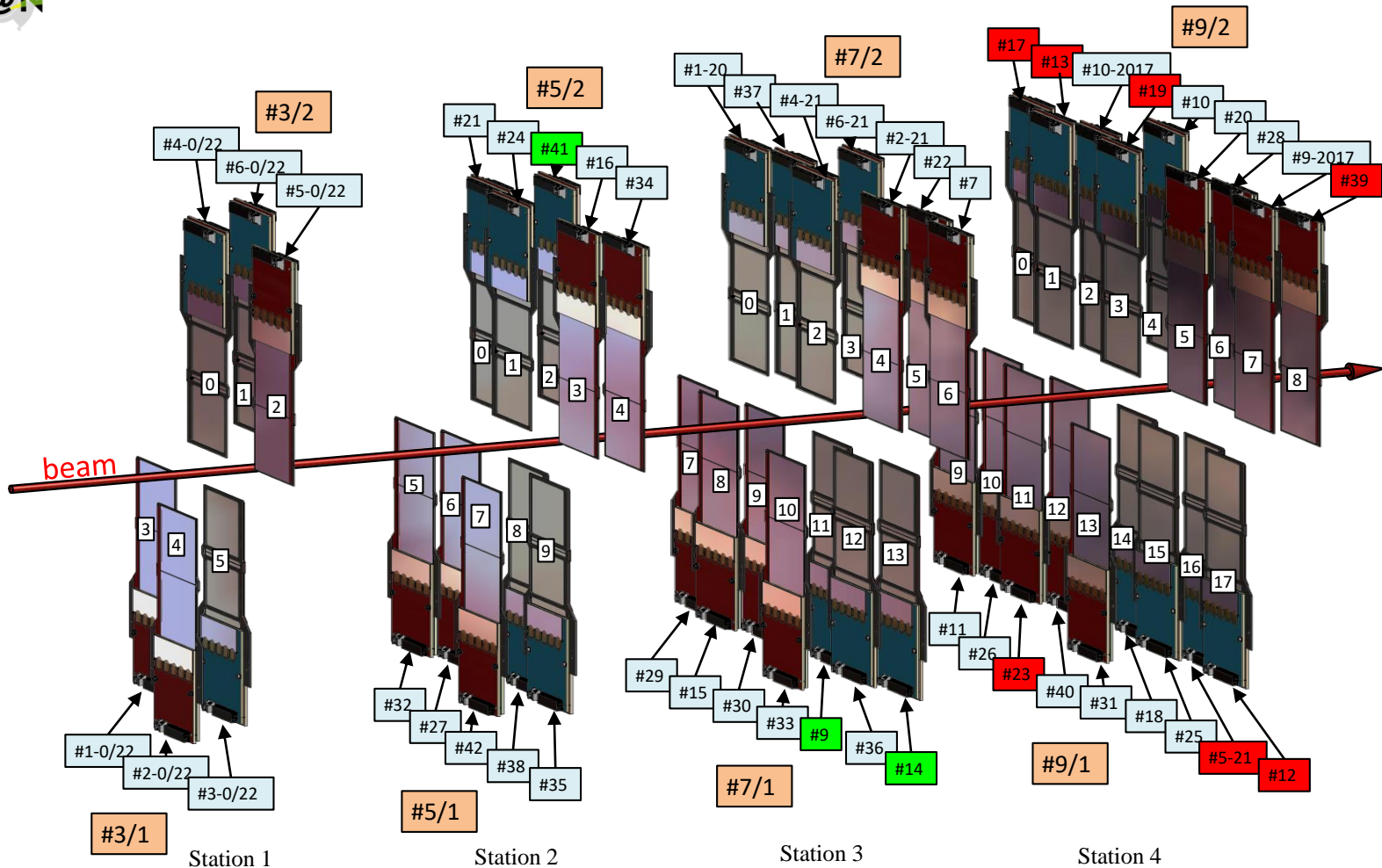
49 and 50th strips are shorted out on the detector. Irreparable defect

Linearity of ASICs after PCB tuning ($t_s=240$ nS)

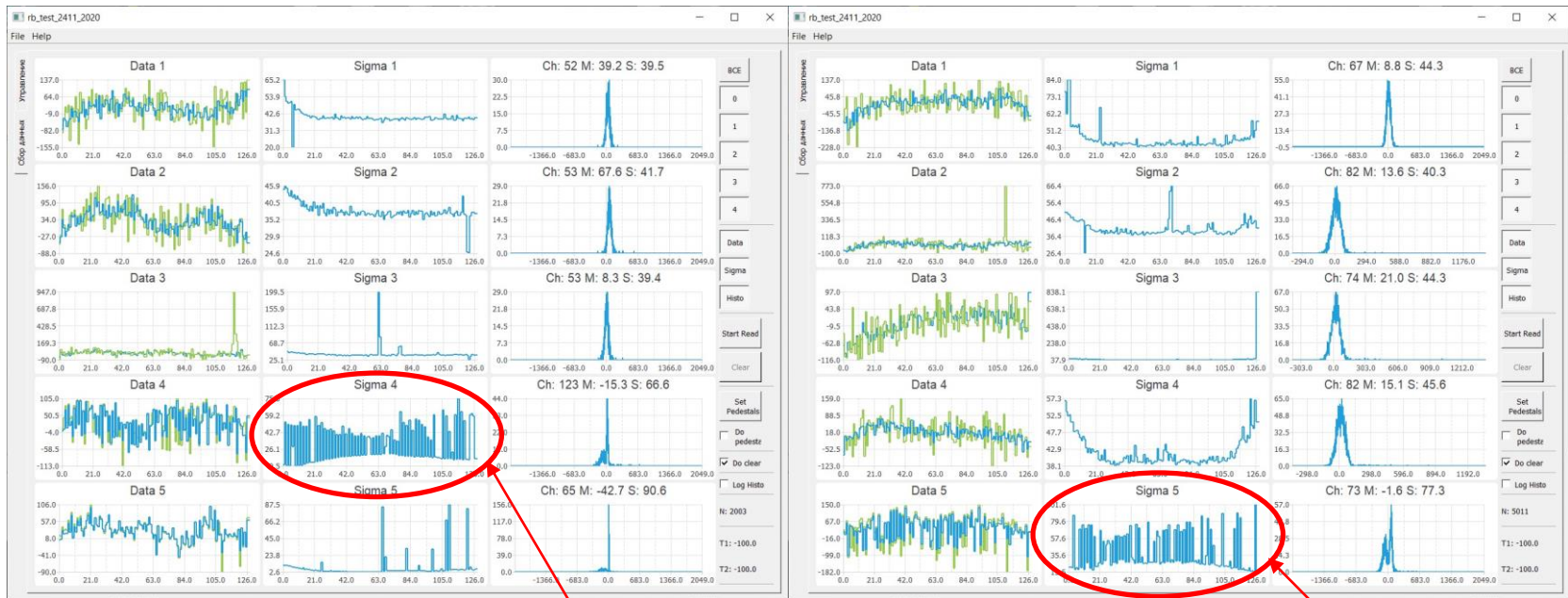


Uniformity of ASICs gain (input 10 pC, $t_s=240$ nS)





Pedestal run



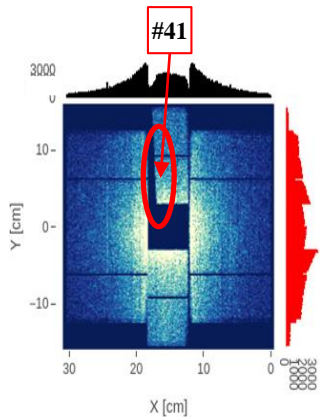
Module 14 (PCB_{p+} #23, defective chip #4)

Module 9 (PCB_{p+} #08, defective chip #5)

FSD planes before repair

Session BM@N 2022 г. – 2023 г.

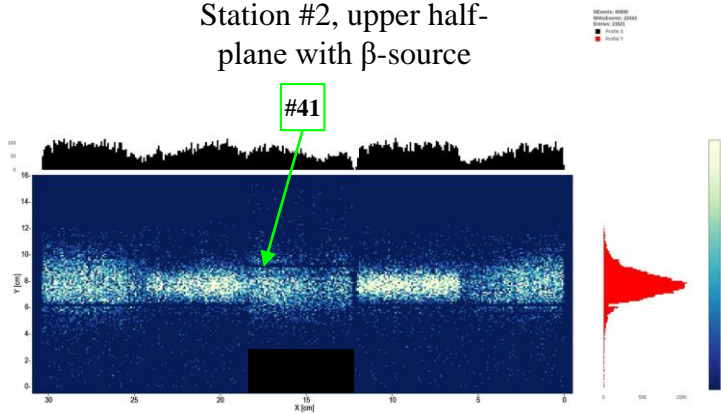
RUN 7529



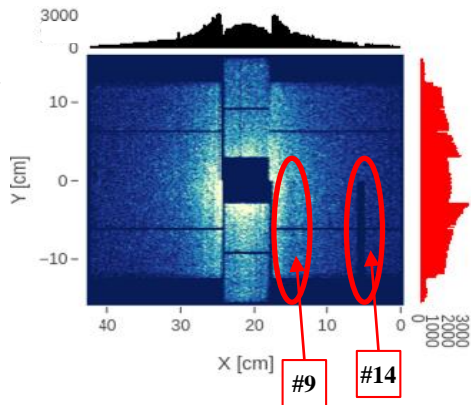
Hits distribution at Station # 2 (10 modules, DSSD 63x63 mm²
1 module = 2 DSSD)

FSD planes after repair

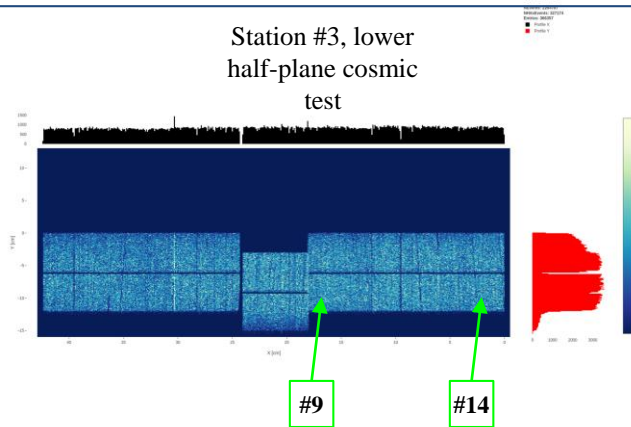
Station #2, upper half-plane with β -source



Hits distribution at Station # 3 (14 modules, DSSD 63x63 mm²
1 module = 2 DSSD)



Station #3, lower half-plane cosmic test



SiBT:

- Study of long time stability of dark current DSSD SiBT-1 ÷ SiBT-3 at room temperature;
- Repair of dead channels at SiBT-1 (72 n+) and SiBT-3 (69 n+);
- Found technological defect at SiBT-3 (shorted 49 p+ and 50 p+), irreparable defect;

FSD:

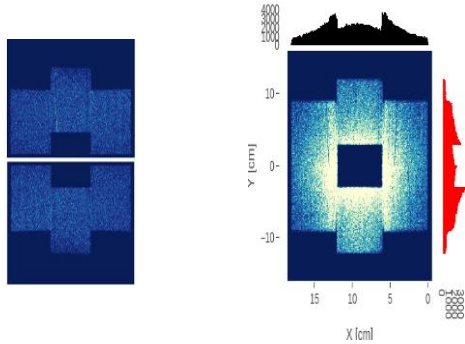
- The IDs of modules with defects in the FSD planes #2, #3, #4 are determined;
- Were assembled new FEE-PCBs: 5 PCB-640 n+ and 5 PCB-640 p+, should be assembled 8 new PCB-640 p+;
- For FSD plane #4 (18 modules) should be repaired 7 modules;
- FSD plane #2 (10 modules), FSD plane #3 (14 modules) are ready without dead chips;
- FSD planes (1 ÷ 4) should be ready for installation on BM@N experimental hall before 31 December.

BACKUP

Analysis of the work of Si-planes FSD in Xe-run

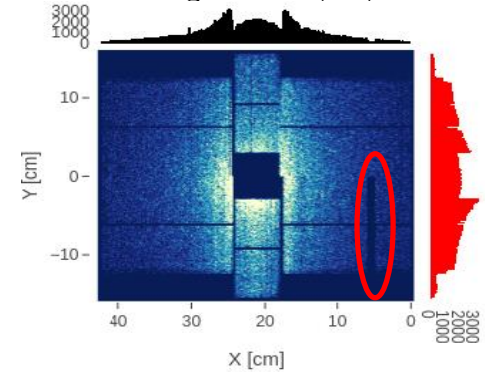
█ defects before BM@N session
█ defects after BM@N session

Cosmic tests
 Session BM@N 2022 г. – 2023 г.
 RUN 7529 (11.01.2023), $t_c = 25,2^\circ\text{C}$
 Target №2 CsI (2%)



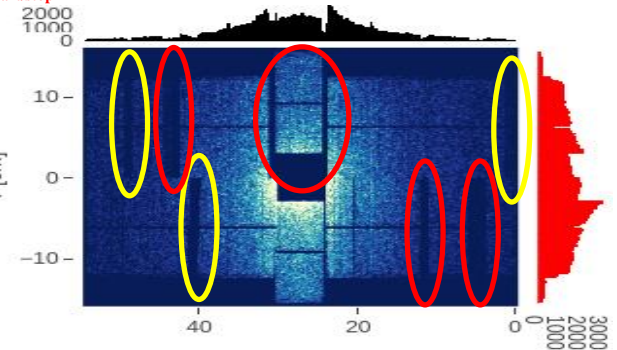
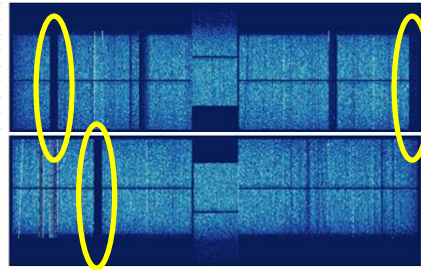
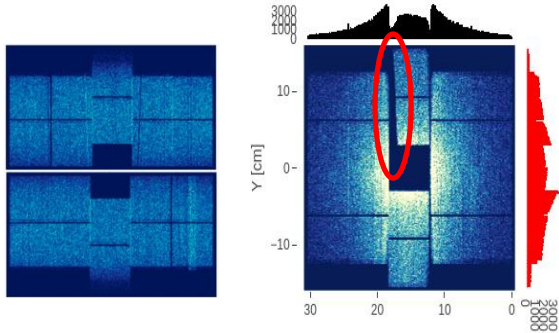
Cosmic tests

Session BM@N 2022 г. – 2023 г.
 RUN 7529 (11.01.2023), $t_c = 25,2^\circ\text{C}$
 Target №2 CsI (2%)



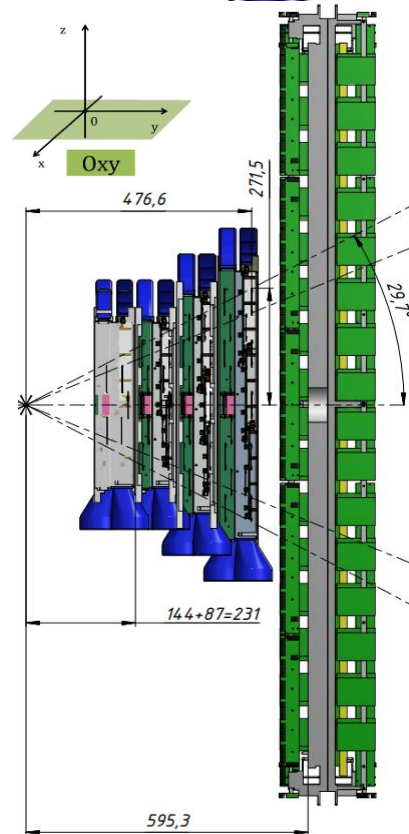
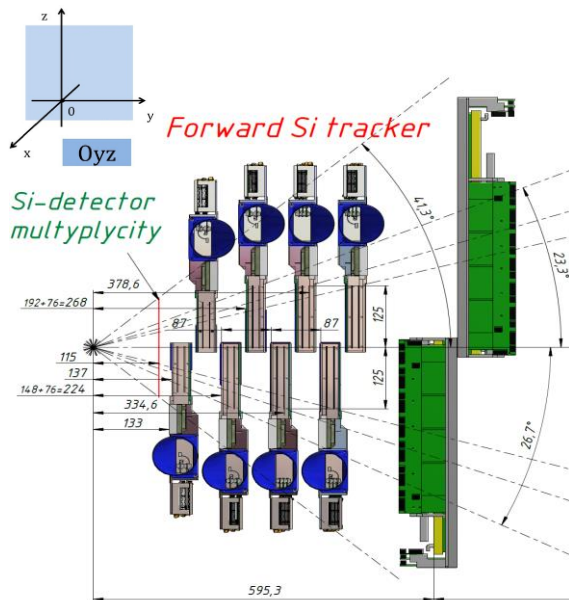
Hits distribution at Station # 0 (6 modules, DSSD 63x93 mm²,
 1 module = 1 DSSD) $I_{\text{start/stop}} = 8,99 / 8,21 \mu\text{A} (06.12 / 01.02)$

Hits distribution at Station # 2 (14 modules, DSSD 63x63 mm²
 1 module = 2 DSSD) , $I_{\text{start/stop}} = 27,6 / 28,5 \mu\text{A} (06.12 / 01.02)$



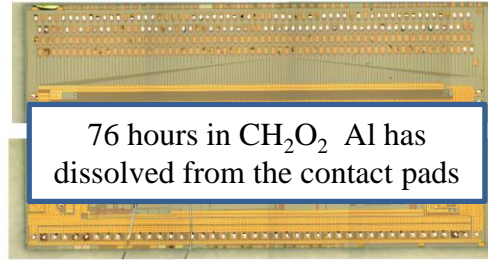
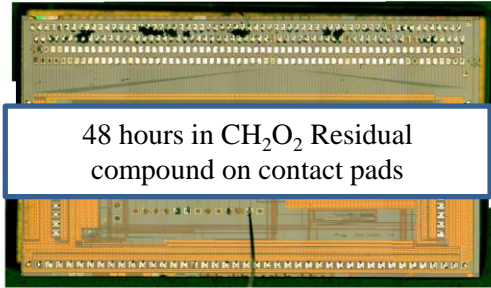
Hits distribution at Station # 1 (10 modules, DSSD 63x63 mm²
 1 module = 2 DSSD) $I_{\text{start/stop}} = 40,7 / 48,33 \mu\text{A} (06.12 / 01.02)$

Hits distribution at Station # 3 (18 modules DSSD 63x63 mm²
 1 module = 2 DSSD) $I_{\text{start/stop}} = 6,9 / 7,38 \mu\text{A} (06.12 / 01.02)$



6 black PCBs and 1 red PCB are needed to eliminate all dead zones on station #4

Location of FSD planes in session 2023 (side OXY)



Work was performed to de-encapsulate the black BE-08 compound from the electronics boards without damaging the ASICs and aluminum contact tracks in order to extract working ASICs

The following solvents were used:

- Dimethyl sulfoxide - $\text{C}_2\text{H}_6\text{SO}$
- Dimethylformamide - $\text{C}_3\text{H}_7\text{NO}$

The compound BE-08 degrades very slowly.

The following scheme was used:

Soaked for 48 hours in CH_2O_2 , removed the compound residue in a 1:1 solution of $\text{C}_2\text{H}_6\text{SO} + \text{C}_3\text{H}_7\text{NO}$.

To date, extracted 3 chips from 4 non-working boards.

FSD station #4

